p-ISSN 2083-0157, e-ISSN 2391-6761

DOI: 10.5604/01.3001.0010.4589

# COUPLING BOUNDARY ELEMENT METHOD WITH LEVEL SET METHOD TO SOLVE INVERSE PROBLEM

### Tomasz Rymarczyk<sup>1</sup>, Paweł Tchórzewski<sup>1</sup>, Jan Sikora<sup>2,3</sup>

<sup>1</sup>Netrix S.A., Research and Development Center, Związkowa Str. 26, 20-148 Lublin, <sup>2</sup>Lublin University of Technology, Institute of Electronics and Information Technology, <sup>3</sup>Electrotechnical Institute

Abstract. The boundary element method and the level set method can be used in order to solve the inverse problem for electric field. In this approach the adjoint equation arises in each iteration step. Results of the numerical calculations show that the boundary element method can be applied successfully to obtain approximate solution of the adjoint equation. The proposed solution algorithm is initialized by using topological sensitivity analysis. Shape derivatives and material derivatives have been incorporated with the level set method to investigate shape optimization problems. The shape derivative measures the sensitivity of boundary perturbations. The coupled algorithm is a relatively new procedure to overcome this problem. Experimental results have demonstrated the efficiency of the proposed approach to achieve the solution of the inverse problem.

Keywords: inverse problem, boundary element method, level set method

## POŁĄCZENIE METODY ELEMENTÓW BRZEGOWYCH I ZBIORÓW POZIOMICOWYCH W ROZWIĄZYWANIU ZAGADNIENIA ODWROTNEGO

Streszczenie. Metoda elementów brzegowych i metoda zbiorów poziomicowych mogą być wykorzystane to rozwiązania zagadnienia odwrotnego pola elektrycznego. W takim podejściu równanie sprzężone jest rozwiązywane w każdym kroku iteracyjnym. Wyniki obliczeń numerycznych pokazują, że metoda elementów brzegowych może być zastosowana z powodzeniem do uzyskania przybliżonego rozwiązania równania sprzężonego. Proponowany algorytm jest inicjalizowany za pomocą topologicznej analizy wrażliwościowej. Pochodna kształtu i pochodna materialna zostały połączone z metodą zbiorów poziomicowych w celu zbadania problemów optymalizacji kształtu. Pochodna kształtu mierzy wrażliwość perturbacji brzegowych. Zespolony algorytm jest stosunkowo nową procedurą do rozwiązania tego problemu. Wyniki doświadczenia pokazały skuteczność proponowanego podejścia w rozwiązywaniu zagadnienia odwrotnego.

Slowa kluczowe: zagadnienie odwrotne, metoda elementów skończonych, tomografia impedancyjna

#### Introduction

The electrical impedance is non-destructive imaging technique [14, 15], which has various applications. For example, it can be used in medical imaging. In our approach the algorithm of the inverse problem bases on the boundary element method (BEM) [4, 13], the gradient technique and the level set method [1, 2, 5–7, 12, 16, 17]. In the gradient technique so-called adjoint equation has to be solved [3, 8–11]. The solution has to be obtained in each iteration step. Numerical techniques give us opportunity to find approximate solutions of differential equations which cannot be solved by means of analytical ones. Among various numerical tools like the finite element method, the finite difference method or BEM we concentrated our attention on the last one. BEM can be effectively employed on condition that partial differential equation can be transformed to integral form. Additionally, the Green's function has to be calculated. In our numerical calculations for simplicity zero order approximation has been chosen. The function which describes electrical conductivity distribution in our system possesses two different nonzero values. Finally, we have successfully solved the inverse problem in twodimensional system with 16 electrodes. Therefore, the proposed numerical model has been verified.

#### 1. Boundary Element Method

The field studies might be split on two main branches. In that case are defined: the topology of the structure (interface boundary – outside and/or inside), boundary conditions, material coefficients (e.g. conductivity), the internal source or sources etc. The second case concerns with the inverse problem solution. In this case the unknown parameters are searched when the field distribution is known. Unknown shape of the interface could play the role of the unknown parameters and the inverse problem could be called for example Electrical Impedance Tomography (EIT). Normally we only known the field distribution on the most external boundary of the object.

The partial differential equation in its integral form was defined in order to compute the field distribution for the inhomogeneous regions presented in Figure 1:

$$\begin{split} c(\overrightarrow{r_{l}})\Phi_{1}(\overrightarrow{r_{l}}) + \int\limits_{\Gamma_{1}+\Gamma_{2}+\Gamma_{3}} \Phi_{1}(\overrightarrow{r}) \frac{\partial G_{1}(\overrightarrow{r},\overrightarrow{r_{l}})}{\partial n} d\Gamma \\ &= \int\limits_{\Gamma_{1}+\Gamma_{2}+\Gamma_{3}} G_{1}(\overrightarrow{r},\overrightarrow{r_{l}}) \frac{\partial \Phi_{1}(\overrightarrow{r})}{\partial n} d\Gamma \\ c(\overrightarrow{r_{l}})\Phi_{2}(\overrightarrow{r_{l}}) + \int\limits_{\Gamma_{2}} \Phi_{2}(\overrightarrow{r}) \frac{\partial G_{2}(\overrightarrow{r},\overrightarrow{r_{l}})}{\partial n} d\Gamma = \int\limits_{\Gamma_{2}} G_{2}(\overrightarrow{r},\overrightarrow{r_{l}}) \frac{\partial \Phi_{2}(\overrightarrow{r})}{\partial n} d\Gamma \\ c(\overrightarrow{r_{l}})\Phi_{3}(\overrightarrow{r_{l}}) + \int_{\Gamma_{3}} \Phi_{3}(\overrightarrow{r}) \frac{\partial G_{3}(\overrightarrow{r},\overrightarrow{r_{l}})}{\partial n} d\Gamma = \int_{\Gamma_{3}} G_{3}(\overrightarrow{r},\overrightarrow{r_{l}}) \frac{\partial \Phi_{3}(\overrightarrow{r})}{\partial n} d\Gamma (1) \\ \text{where the value of $c$ coefficient is defined by the location of the point indicated by the position vector $\overrightarrow{r_{l}}$:} \end{split}$$

$$c(\vec{r_i}) = \begin{cases} 1, & \vec{r_i} \in \Omega \\ \frac{1}{2}, & \vec{r_i} \in \partial\Omega \\ 0, & \vec{r_i} \notin \Omega \end{cases}$$
 (2)

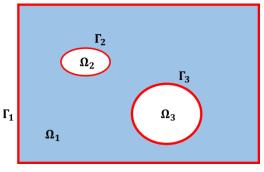


Fig. 1. The example of the structure: region  $\Omega_1$  limited by border  $\Gamma_1$  with two internal objects:  $\Omega_2$  limited by border  $\Gamma_2$  and  $\Omega_3$  limited by border  $\Gamma_3$ 

The objective is to find interface (inside boundary) using voltage measurements on the periphery of the region. The boundary  $\Gamma_1$  is known, but the starting shape of interface in request has been chosen randomly (at the beginning of the iteration process). For so called "current electrodes" (nodes of the boundary elements) the Dirichlet boundary conditions are imposed (emulate the voltage source), for the rest (the "voltage electrodes") the homogeneous Neumann boundary condition  $\frac{\partial \Phi}{\partial n} = 0$  are imposed.

The state function (electric potential) and its normal derivative on the particular boundary  $\Gamma_1$ ,  $\Gamma_2$ ,  $\Gamma_3$  of each substructures  $\Omega_1$ ,  $\Omega_2$ ,  $\Omega_3$  are denoted as:

$$\begin{split} & \boldsymbol{\Phi}_{1}(\Gamma_{1}) = \boldsymbol{\Phi}_{1}^{1}, \ \boldsymbol{\Phi}_{1}(\Gamma_{2}) = \boldsymbol{\Phi}_{2}^{1}, \boldsymbol{\Phi}_{1}(\Gamma_{3}) = \boldsymbol{\Phi}_{3}^{1}, \\ & \boldsymbol{\Phi}_{2}(\Gamma_{2}) = \boldsymbol{\Phi}_{2}^{2}, \boldsymbol{\Phi}_{3}(\Gamma_{3}) = \boldsymbol{\Phi}_{3}^{3}, \\ & \frac{\partial \boldsymbol{\Phi}_{1}(\Gamma_{1})}{\partial n} = \left(\frac{\partial \boldsymbol{\Phi}}{\partial n}\right)_{1}^{1}, \frac{\partial \boldsymbol{\Phi}_{1}(\Gamma_{2})}{\partial n} = \left(\frac{\partial \boldsymbol{\Phi}}{\partial n}\right)_{2}^{1}, \\ & \frac{\partial \boldsymbol{\Phi}_{1}(\Gamma_{3})}{\partial n} = \left(\frac{\partial \boldsymbol{\Phi}}{\partial n}\right)_{3}^{1}, \frac{\partial \boldsymbol{\Phi}_{2}(\Gamma_{2})}{\partial n} = \left(\frac{\partial \boldsymbol{\Phi}}{\partial n}\right)_{2}^{2}, \\ & \frac{\partial \boldsymbol{\Phi}_{3}(\Gamma_{3})}{\partial n} = \left(\frac{\partial \boldsymbol{\Phi}}{\partial n}\right)_{3}^{3} \end{split}$$
(3)

Substitute:

$$A_{ij}^* = \int_{\Gamma_j} \frac{\partial G(\vec{r_i}, \vec{r})}{\partial n} d\Gamma \tag{4}$$

 $A_{ij}^* = \int_{\Gamma_j} \frac{\partial G(\vec{r_i} \cdot \vec{r})}{\partial n} d\Gamma$  where  $A_{ij} = \begin{cases} A_{ij}^*, & i \neq j \\ A_{ij}^* + c(\vec{r_i}), i = j \end{cases}$  and

$$B_{ij} = \int_{\Gamma_i} G(\vec{r}_i, \vec{r}) \, d\Gamma \tag{5}$$

we will rewrite eq. (1) in a matrix form. The same manner was used to mark the matrices A and B as the state function and its normal derivative (see equation (3)):

$$\begin{aligned} & \mathbf{A}^{1}(\Gamma_{1}) = \mathbf{A}_{1}^{\hat{1}}, \mathbf{A}^{1}(\Gamma_{2}) = \mathbf{A}_{2}^{1}, \mathbf{A}^{1}(\Gamma_{3}) = \mathbf{A}_{3}^{1}, \\ & \mathbf{A}^{2}(\Gamma_{2}) = \mathbf{A}_{2}^{2}, \mathbf{A}^{3}(\Gamma_{3}) = \mathbf{A}_{3}^{3}, \\ & \mathbf{B}^{1}(\Gamma_{1}) = \mathbf{B}_{1}^{1}, \mathbf{B}^{1}(\Gamma_{2}) = \mathbf{B}_{2}^{1}, \\ & \mathbf{B}^{1}(\Gamma_{3}) = \mathbf{B}_{3}^{1}, \mathbf{B}^{2}(\Gamma_{2}) = \mathbf{B}_{2}^{2}, \\ & \mathbf{B}^{3}(\Gamma_{3}) = \mathbf{B}_{3}^{3} \end{aligned} \tag{6}$$

The voltage on the internal boundary (interface)  $\Gamma_2$  or  $\Gamma_3$  fulfill the continuous conditions:

conductivity of  $\Omega_3$  is  $\gamma_3$  (as it was previously noted: the conductivity in objects are constant) then:

$$\gamma_1 \frac{\mathbf{\Phi}_1(\Gamma_2)}{\partial n} = -\gamma_2 \frac{\mathbf{\Phi}_2(\Gamma_2)}{\partial n} \\
\gamma_1 \frac{\mathbf{\Phi}_1(\Gamma_3)}{\partial n} = -\gamma_3 \frac{\mathbf{\Phi}_3(\Gamma_3)}{\partial n} \tag{8}$$

where: minus means the opposite direction of the normal unit vector to the border of  $\Omega_1 - \Omega_2$  and  $\Omega_1 - \Omega_3$ .

Rewrite equations for inhomogeneous regions in the matrix form we have got:

$$\begin{bmatrix} A_{2}^{1} & -B_{2}^{1} & A_{3}^{1} & -B_{3}^{1} \\ A_{2}^{2} & -\left(-\frac{\gamma_{1}}{\gamma_{2}}\right)B_{2}^{2} & \mathbf{0} & \mathbf{0} \\ \mathbf{0} & \mathbf{0} & A_{3}^{3} & -\left(-\frac{\gamma_{1}}{\gamma_{3}}\right)B_{3}^{3} \end{bmatrix} \begin{bmatrix} \mathbf{\Phi}_{2}^{1} \\ \frac{\partial \mathbf{\Phi}}{\partial n} \\ \mathbf{\Phi}_{3}^{1} \\ \frac{\partial \mathbf{\Phi}}{\partial n} \\ \end{bmatrix}_{1}^{1} = \begin{bmatrix} -A_{1}^{1}\mathbf{\Phi}_{1}^{1} + B_{1}^{1}\left(\frac{\partial \mathbf{\Phi}}{\partial n}\right)_{1}^{1} \\ \mathbf{0} \\ \mathbf{0} \end{bmatrix}$$
(9)

where the following values  $\Phi_2^1$ ,  $\left(\frac{\partial \Phi}{\partial n}\right)_2^1$ ,  $\Phi_3^1$ ,  $\left(\frac{\partial \Phi}{\partial n}\right)_3^1$  are unknown. It is needed to solve the equation (1) for all projection angles.

#### 2. Inverse Problem

To solve the inverse problem with the aid of the level set method there was needed the adjoint equation. Let us consider the following partial differential equation in two-dimensional Cartesian coordinate system:

$$\nabla \cdot [\sigma(\vec{r})\nabla\lambda(\vec{r})] = b(\vec{r}) \tag{10}$$

where  $\vec{r} \in \Omega$ . We assumed that  $\sigma(\vec{r})$  denotes electrical conductivity distribution. The source term  $b(\vec{r})$  is defined only on the boundary of the domain  $\Omega$ . It depends on differences between voltages obtained from measurements and numerical simulations. The source term has to be calculated on each iteration step. The formula for  $b(\vec{r})$  is given in [13]. Additionally, we assumed that the adjoint function  $\lambda$  or its normal derivative  $\beta$  is known for all boundary points. The differential problem defined in described manner may be regarded as the boundary value problem for the adjoint equation (10).

Starting point for our research is typical for BEM integral equation [13], where the boundary curve is divided into N

$$c(\vec{r_i})\lambda(\vec{r_i}) + \sum_{j=1}^{N} \int_{\Gamma_j} \lambda(\vec{r}) h(\vec{r}, \vec{r_i}) d\gamma_j + \int_{\Omega} b(\vec{r}) g(\vec{r}, \vec{r_i}) d\omega =$$

$$= \sum_{j=1}^{N} \int_{\Gamma_i} \beta(\vec{r_i}) g(\vec{r}, \vec{r_i}) d\gamma_j$$
(11)

Equation (11) is valid if the electrical conductivity is constant in the whole domain. In the case of constant boundary elements only three values of the function c are possible. If a given point belongs to boundary of the domain  $\Omega$ , then the value equals 0.5. The value of function c equals 1, when a given point lies inside of  $\Omega$  and equals 0 in other cases. The Green's function g may be obtained by solving the fundamental equation and is given by:

$$g(\vec{r}, \vec{r_l}) = \frac{1}{2\pi} ln \left( \frac{A}{|\vec{r} - \vec{r_l}|} \right)$$
 (12)  
In above formula  $A$  is a positive constant. Function  $h$ 

represents the derivative of the Green's function in normal direction appointed by unit vector  $\vec{n}(\vec{r})$ . After calculations we get:

threetion appointed by unit vector 
$$h(\vec{r})$$
. After calculations we get:  

$$h(\vec{r}, \vec{r_l}) = -\frac{1}{2\pi} \frac{\vec{n}(\vec{r}) \cdot (\vec{r} - \vec{r_l})}{|\vec{r} - \vec{r_l}|^2}$$
(13)
The vector formula for *j*-th constant boundary element is given by:

$$\vec{\mathbf{r}}_{j}(\xi) = \vec{r}_{(m)j} + 0.5(\vec{r}_{(l)j} - \vec{r}_{(f)j})\xi$$
 (14)

where  $\xi \in (-1,1)$ . Position vectors  $\vec{r}_{(f)j}$ ,  $\vec{r}_{(l)j}$  and  $\vec{r}_{(m)j}$  represent the first vertex, the last vertex and the middle point (node) of j-th boundary element, respectively. We use constant boundary elements, therefore:

$$c(\vec{r_i})\lambda(\vec{r_i}) + \sum_{j=1}^{N} \lambda(\vec{r}) \int_{\Gamma_j} h(\vec{r}, \vec{r_i}) d\gamma_j + \int_{\Omega} b(\vec{r}) g(\vec{r}, \vec{r_i}) d\omega =$$

$$= \sum_{j=1}^{N} \beta(\vec{r_i}) \int_{\Gamma_j} g(\vec{r}, \vec{r_i}) d\gamma_j$$
(15)

Formulas (12), (13), and (15) can be utilised to solve the adjoint equation (10) because the domain  $\Omega$  can be decomposed into two subdomains where electrical conductivity is constant for each one.

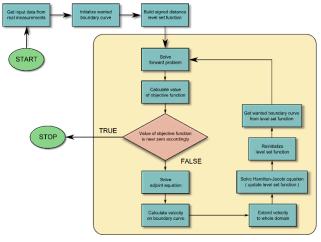


Fig. 2. The scheme of the algorithm to minimize the objective function

The following algorithm is used to find out the shape and the position of the unknown internal obstacles (Fig. 2):

- make discretization of the outer boundary  $\Gamma_1$  (for example on 32 elements),
- collect measurements from the electrodes for all projection angles,
- conduct simulation for randomly placed objects inside,
- use the Laplace equation and compute electric potential distribution with the aid of BEM,
- determine difference between the "measured"  $\boldsymbol{u}_0$  and computed potential  $\Phi$  and use them for the adjoint equation,
- update the Hamilton-Jacobi equation,
- check if it's necessary to reinitialize set level function,
- get zero level contour of updated  $\varphi$  function and select discretization points,
- calculate the objective function according to the equation

$$F_{c} = \frac{1}{2} \sum_{j=1}^{p} F_{j} = \frac{1}{2} \sum_{j=1}^{p} \left\{ \left( \mathbf{\Phi}_{1j}^{1} - \mathbf{u}_{0j} \right)^{T} \left( \mathbf{\Phi}_{1j}^{1} - \mathbf{u}_{0j} \right) \right\}$$
(16)

where:  $\Phi$  – is computed electric potential distribution;  $\dot{u}_0$  – is measured values for real object, if the objective function is lower than assumed threshold, then "stop", else go to the point (d).

#### 3. Results

Figure 3 shows the solution of the inverse problem. All points in both figures represent vertices of boundary elements. Our algorithm needed about 50 iterations to minimalize the objective function (see Fig. 4). Obtained result is appropriate. Proposed numerical model has been successfully verified. We can make use of BEM in algorithm which solves the inverse problem in EIT.

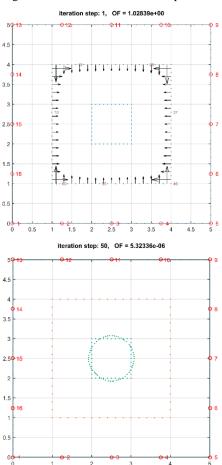
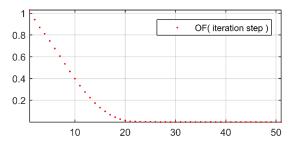


Fig. 3. The solution of the inverse problem (green points). internal square indicated by blue points represents proper position of the interface, orange points represent initial position of the interface, symbol OF denotes the value of the objective function



 $Fig.\ 4.\ The\ objective\ function\ versus\ the\ number\ of\ iteration\ step$ 

Figure 5 presents the image reconstruction with the one object. Figure 6a shows two obstacles marked by the blue dashed line. Such a test example will be considered as an EIT problem. The phantom object with unknown topology inside was reconstructed. In such case the level set function with four zero level objects will be applied as most appropriate one. For each simulated object the velocity would be calculated under assumption that the conductivities of all objects are known. Unknown structures are

marked by the blue line; simulated objects are marked by the red line. For last 300 iterations step the unknown structure was found. The result is presented in Figure 6d. The objective function distribution versus the number of iteration steps is shown in Figure 7.

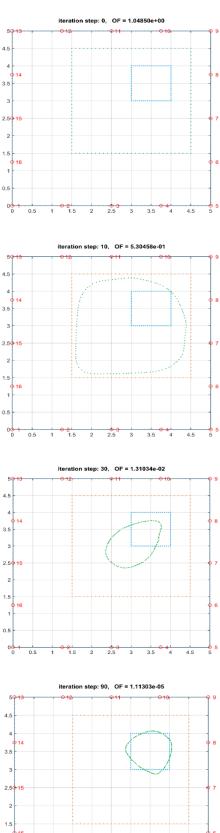


Fig. 5. The image reconstruction of the one object (BEM-LSM)

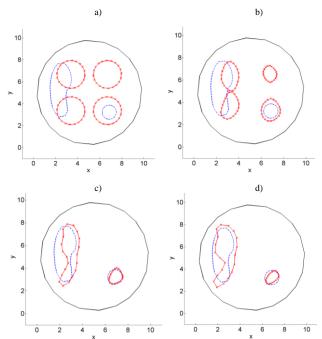


Fig. 6. The black line marks the outside border of the structure with the internal unknown objects (marked by the blue dashed line). The red line marks zero level contours, a) starting point, b) after 98 iterations, one step before merging two objects, c) after 225 iterations with the lowest value of the cost function equal to=0.96; d) after 300 iteration steps when the objective functions again increased

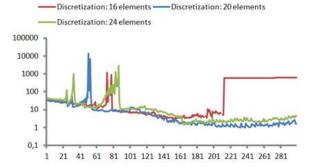


Fig. 7. The objective function distribution versus the number of iteration steps

#### 4. Conclusion

The inverse problem was solved using the combination of the level set function with the boundary element. The level set method and BEM show a way how to compute the interface by updating the Hamilton-Jacobi equation. This is particularly easy when the BEM is applied because the normal derivatives of the state function and adjoint function are the primary values directly achieved after the simulation process. In many cases occurs that the reinitialization is necessary to fix the correct shape of the level set function and also the signed distance function. Experimental results confirmed that presented method is efficient and the only one which is able to change the topology during the iteration process.

#### References

- Allaire G., Gournay F. De, Jouve F., Toader A. M.: Structural optimization using topological and shape sensitivity via a level set method, Control and Cybernetics, vol. 34, 2005, 59-80.
- [2] Chen W., Cheng J., Lin W.: A level set method to reconstruct the discontinuity of the conductivity in EIT, Science in China Series A: Mathematics, vol. 52,
- Ito K., Kunish K., Li Z.: The Level-Set Function Approach to an Inverse Interface Problem, Inverse Problems, vol. 17, no. 5, 2001, 1225–1242.

- Jabłoński P.: Metoda elementów brzegowych w analizie elektromagnetycznego, Wydawnictwo Politechniki Częstochowskiej, 2003.
- Osher S., Sethian J. A.: Fronts Propagating with Curvature Dependent Speed: Algorithms Based on Hamilton-Jacobi Formulations, Journal of Computational Physics, vol. 79, 1988, 12-49.
- Osher S., Santosa F.: Level set methods for optimization problems involving geometry and constraints. Frequencies of a two-density inhomogeneous drum, Journal of Computational Physics, vol. 171, 2001, 272-288.
- Osher S., Fedkiw R.: Level Set Methods and Dynamic Implicit Surfaces, Springer New York, 2003.
- [8] Rymarczyk T.: Using electrical impedance tomography to monitoring flood banks, International Journal of Applied Electromagnetics and Mechanics 45, 2014, 489-494.
- Rymarczyk T.: Characterization of the shape of unknown objects by inverse numerical methods, Przegląd Elektrotechniczny, R. 88, 7b, 2012, 138-140.
- Rymarczyk T., Sikora J., Waleska B.: Coupled Boundary Element Method and Level Set Function for Solving Inverse Problem in EIT, 7th World Congress
- on Industrial Process Tomography, WCIPT7, Krakow 2013. Rymarczyk:T., Adamkiewicz P., Duda K., Szumowski J., Sikora J.: New Electrical Tomographic Method to Determine Dampness in Historical Buildings, Achieve of Electrical Engineering, v.65, 2/2016, 273–283
- Sethian J.A.: Level Set Methods and Fast Marching Methods, Cambridge Univeristy Press, 1999.
- Sikora J.: Boundary Element Method for Impedance and Optical Tomography, Warsaw University of Technology Publisher, 2007.
- Smolik W, Forward Problem Solver for Image Reconstruction by Nonlinear Optimization in Electrical Capacitance Tomography, Flow Measurement and Instrumentation, Vol. 21, Issue 1, 2010, 70–77.
- Wajman R., Fiderek P., Fidos H., Jaworski T., Nowakowski J., Sankowski D., Banasiak R.: Metrological evaluation of a 3D electrical capacitance tomography measurement system for two-phase flow fraction determination; Meas. Sci. Technol. Vol. 24, 2013, No. 065302.
- Tai C., Chung E., Chan T.: Electrical impedance tomography using level set representation and total variational regularization, Journal of Computational Physics, vol. 205, no. 1, 2005, 357–372.
- Vese L., Chan T.: A new multiphase level set framework for image segmentation via the Mumford and Shah model. CAM Report 01-25, UCLA Math. Dept., 2001.

## Ph.D. Eng. Tomasz Rymarczyk

e-mail: tomasz.rymarczyk@netrix.com.pl

Director in Research and Development Center Netrix S.A. His research area focuses on the application of non-invasive imaging techniques, electrical tomography, image reconstruction, modelling, image processing and analysis, process software engineering, tomography, knowledge engineering, artificial intelligence and computer measurement systems.



#### M.A. Paweł Tchórzewski

e-mail: pawel.tchorzewski@netrix.com.pl

Researcher in R&D Department - Netrix S.A. A graduate of the Maria Curie-Sklodowska University Lublin on the physics (specializing in theoretical physics). Currently, the work carries out tasks profile research and development in the field of numerical methods for solving partial differential equations, electrical tomography in image reconstruction, forward and inverse problem. He is a Ph.D. student of the Institute of Electrical Engineering in Warsaw.



## Prof. Jan Sikora

e-mail: sik59@wp.pl

Prof. Jan Sikora (PhD. DSc. Eng.) graduated from Warsaw University of Technology Faculty of Electrical Engineering. During years professional work he has proceeded all grades, including the position of full professor at his alma mater. Since 1998 he has worked for the Institute of Electrical Engineering in Warsaw. In 2008 he has joined Electrical Engineering and Computer Science Faculty In Lublin University of Technology. During 2001-2004 he has worked as a Senior Research Fellow at University College London in the prof. S. Arridge's Group of Optical Tomography. His research interests are focused on numerical methods for electromagnetic

